

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaharu KAWAKUBO et al.

Application No.: New U.S. National Stage of PCT/JP2004/017447

Filed: May 30, 2006

Docket No.: 127873

For: EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, EXPOSURE
APPARATUS, AND PROGRAM

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.